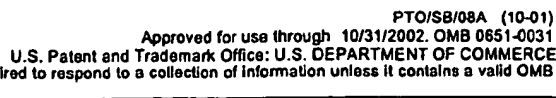


FORM PTO-1449		Docket Number (Optional) 294G 1787-9		Application Number 10/027,726	
INFORMATION DISCLOSURE CITATION IN AN APPLICATION		Applicant Colbert et al.			
(Use several sheets if necessary)		Filing Date 12/21/2001		Group Art Unit 1754	
U.S. PATENT DOCUMENTS					
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	FILING DATE IF APPROPRIATE
FOREIGN PATENT DOCUMENTS					
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	TRANSLATION (YES/NO)
PL	JP H06-331309	12/2/1994	Japan		Yes
PL	JP H06-252056	9/9/1994	Japan		Yes
PL	JP H07-122198	5/12/1995	Japan		Yes
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)					
PL	"Imaging steep, high structures by scanning force microscopy with electron beam deposited tips" by David J. Keller, et al., pages 333-339 in the <i>Surface Science</i> magazine published by Elsevier Science Publishers B.V. in 1992 in Holland				
PL	"New Scanning tunneling microscopy tip for measuring surface topography" by Y. Akama, et al., pages 429-433 in <i>Vac. Sci. Technol. A 8</i> published by American Vacuum Society in 1990				
PL	"Atomic force microscopy using ZnO whisker tip" by H. Kado, et al., pages 3330-3332 in <i>Rev. Sci. Instrum</i> 63 published by American Institute of Physics in 1992				
PL	"Helical microtubules of graphitic carbon" by Sumio Iijima, pages 56-58 in the <i>Nature</i> magazine Vo. 354 published in 1991				
PL	"Single-shell carbon nanotubes of 1-nm diameter" by Sumio Iijima et al., pages 603-605 in the <i>Nature</i> magazine Vo. 363 published in 1993				
PL	"Aligned Carbon Nanotube Arrays Formed by Cutting a Polymer Resin-Nanotube Composite" by P.M. Ajaya, et al., pages 1212-1214 in the <i>SCIENCE</i> magazine Vo. 265 published in 1994				
PL	"Aligned Carbon Nanotube Films: Production and Optical and Electronic Properties" by Walt A. de Heer, et al., pages 845-847 in the <i>SCIENCE</i> magazine Vo. 268 published in 1995				
EXAMINER	DATE CONSIDERED		6/20/05		
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.					



Substitute for form 1449A/PTO <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <i>(use as many sheets as necessary)</i>				<b>Compleat if Known</b>	
				<b>Application Number</b>	10/027.726
				<b>Filing Date</b>	December 21, 2001
				<b>First Named Inventor</b>	Colbert, et al.
				<b>Art Unit</b>	2881
				<b>Examiner Name</b>	Unknown
				<b>Attorney Docket Number</b>	11321-P011C1D8
Sheet	1	of	2		

[illegible][illegible]

Examiner Signature	<i>[Signature]</i>	Date Considered	6/26/05
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

**English Language Requirement is waived.**

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